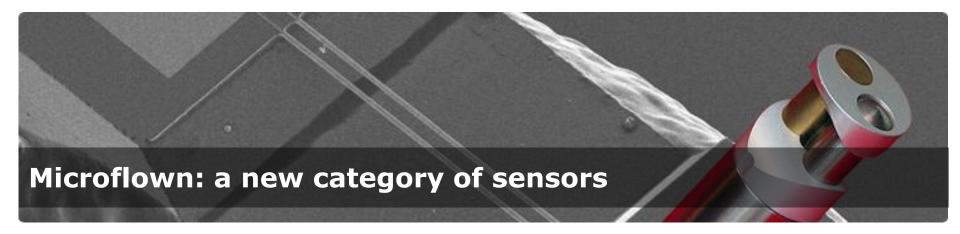


Microflown Technologies The Netherlands <u>www.microflown.com</u> info@microflown.com







Company Introduction

- 1994: Invention Microflown by Hans-Elias de Bree at University Twente
- 1997: Ph.D. Hans-Elias de Bree
- 1998: Founding Microflown Technologies B.V. (de Bree, Koers)
- 2001: Industrializing product
- 2003: Introduction broad banded sensor element
- 2004: First applications scientifically proven / first arrays sold
- 2005: Rapid growth in (automotive + aerospace) industry
- 2005: De Bree appointed Professor 'Vehicle Acoustics' at the HAN University, Arnhem School of Automotive Engineering
- 2008: Strategic decision to explore the defense & security market
- 2011: Microflown Avisa was founded
- 2011: 20 FTE company, 2 MEURO turnover (only Technologies)



Automotive - OEM



Audi, BMW, Chrysler, CNH, DAF Paccar, Daimler, FAW, Fiat, Ford, Freightliner, General Motors, Harley Davidson, Hyundai, Honda, Isuzu, Mahindra, Maruti-Suzuki, Mazda, Merceded Benz, Mitsubishi, Nissan, Porsche, PSA Group (Peugeot - Citroën), Renault Samsung, TATA, Toyota, Volkswagen



Automotive - Others



AISIN, Behr Group, Brose, Bridgestone, Denso, Eaton USA, Faurecia, Fontijne Grotnes, GKN Driveline, Harman Becker Automotive Systems, Hitachi, HP Pelzer, Ideal Automotive, IVM Automotive, Jatco, JTEKT, Kanto Auto Works, LuK, Magneti Marelli, Mirror Controls International, Mitsuba, Rieter Automotive, Rietschle Thomas, Rieter Automotive, Rochling Automotive Robert Bosch, Same Deutz, Siemens VDO, Stankiewicz, Takata Petri, TRW, ZF



Electronic and consumer goods



Apple, Bosch (BSH), Bose, Canon, Electrolux, Hewlett Packard, Kärcher, KAZ inc, Meizhi, Merry Electronics, Nikon, Oticon, Owens Corning, Panasonic, Philips, Pioneer, Sennheiser, Sony, Toshiba, Voith Hydro, Whirlpool

Other Industries

ASML, CAE Engineering and Services, CNAM, EMPA, Fisher-Rosemount, Foxconn, Gardner Denver Thomas, GD Electric Boat, InPro, INRS, INSA, I-Tech, Kashima, Keihin,KNMI, Kobe Seitetsusyo, Koberuko, Midea, MSX International, Nippo Hoso Kyokai, RION, Sick Maihak,



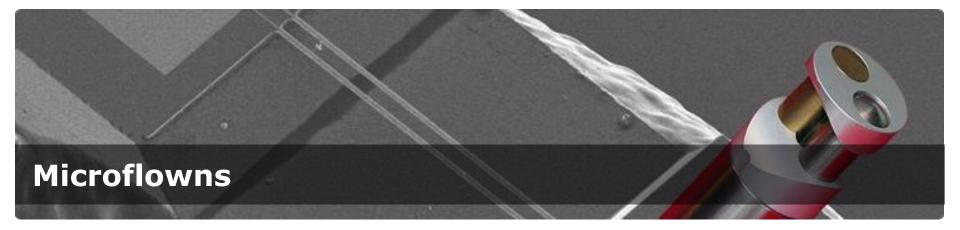


Aeronautical Development Establishment, Alenia Aeronautica, Airbus France, Airbus Germany, DLR (German Aerospace Center), General Electric Propulsion Systems, Gulfstream, Progency Systems Corporation

Test houses and Research insitutes

Autoneum, Batelle Memorial Institue, Carcoustics, FKFS, Fraunhofer, Head Acoustics, HHMI, LMS International, MIRA, Mueller-BBM, NURC (NATO), Ricardo UK, SPEKTRA







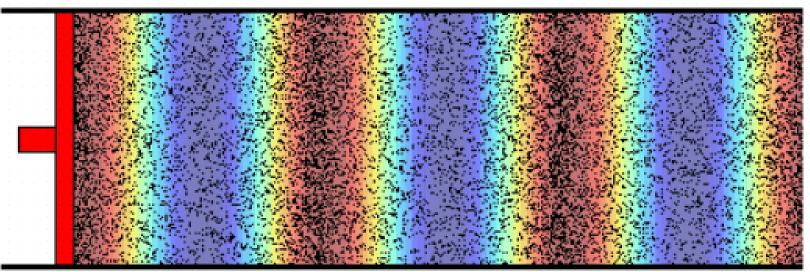
Microphone measures sound pressure (result)

Microflown measures <a>Particle Velocity (cause)

Acoustical	<->	electrical	<->	energy
Sound pressure	<->	voltage	<->	potential
Particle velocity	<->	amperes	<->	kinetic

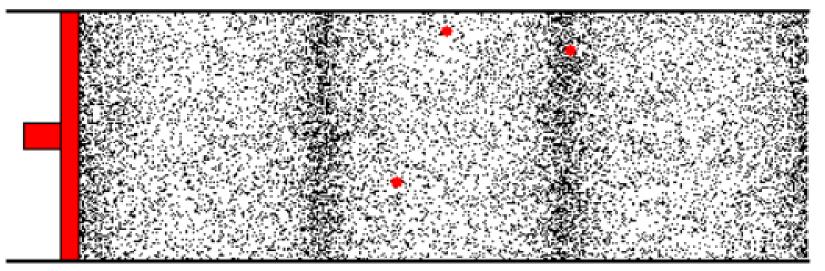


PRESSURE WAVE



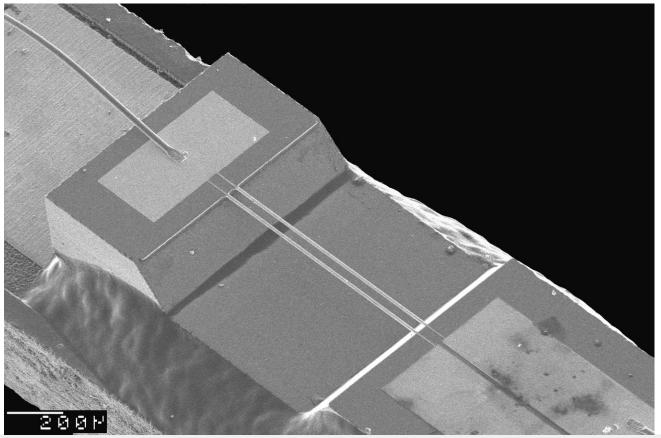


PRESSURE WAVE # PARTICLE VELOCITY

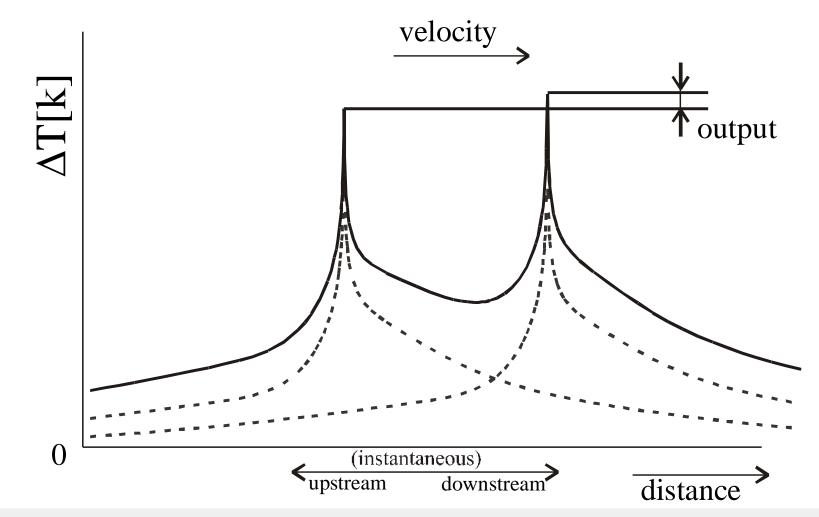




Microflown SEM picture: two heated wires



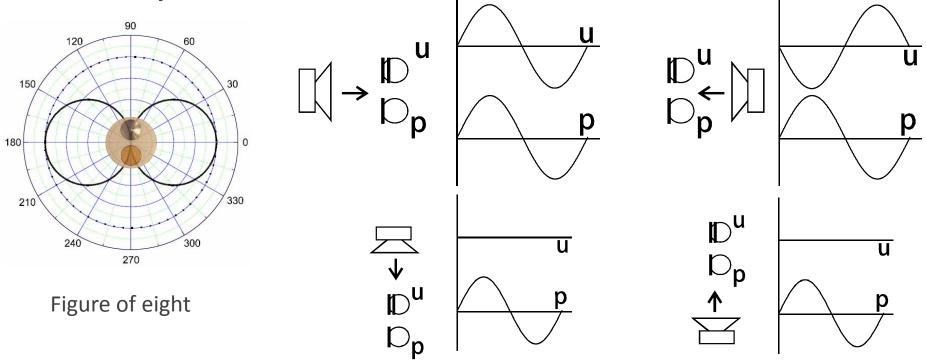






Surface velocity measurement:

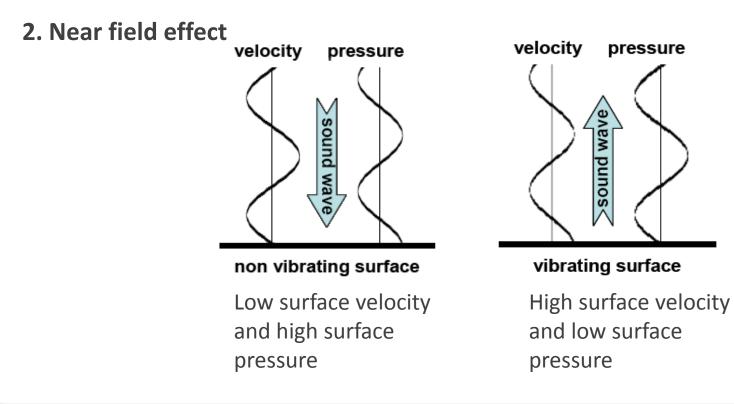
- Low susceptibility background noise and reflection problems
- 1. Directivity





Surface velocity measurement:

• Low susceptibility background noise and reflection problems







Mems based sensor Clean room technology is used to create the small elements on a waver

University of Twente

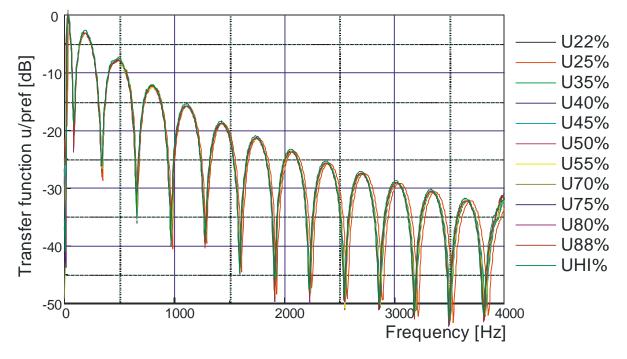


Wirebonded elements





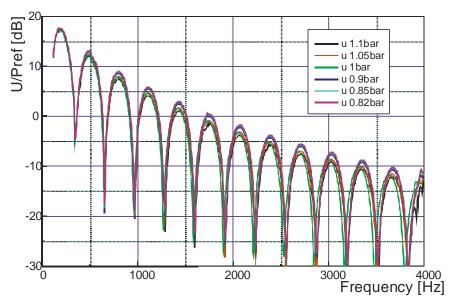
Influence of various humidities

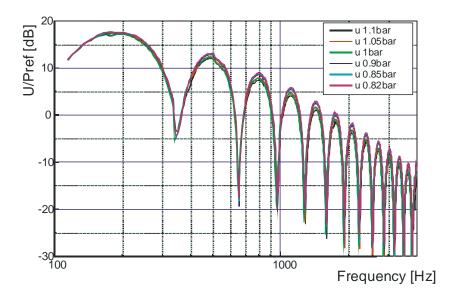


Max deviation of 0.2dB



Influence various static pressure





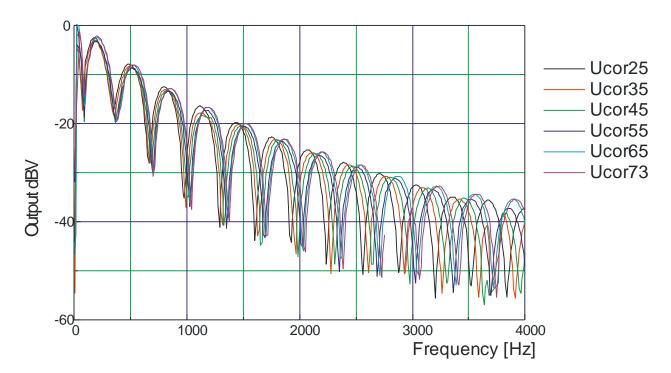
Linear scale

Logaritmic scale

Max deviation of 0.5dB



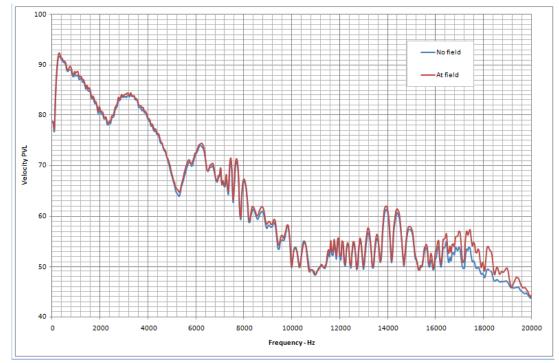
Influence various ambient temperatures



Max deviation less than 1dB (less than 0.02dB/K)



Influence of Magnetic Fields

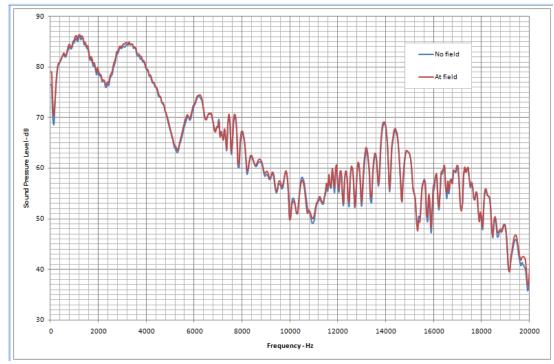


Particle Velocity

Magnetic Field of 6 Tesla



Influence of Magnetic Fields

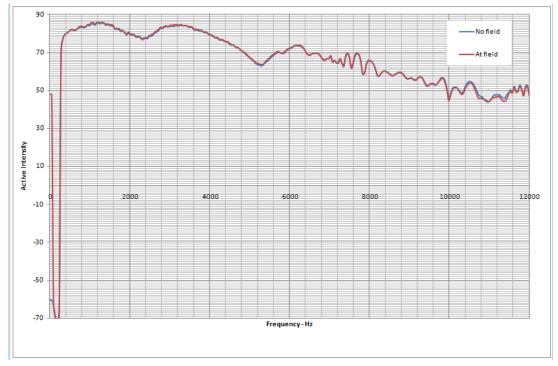


Sound Pressure

Magnetic Field of 6 Tesla



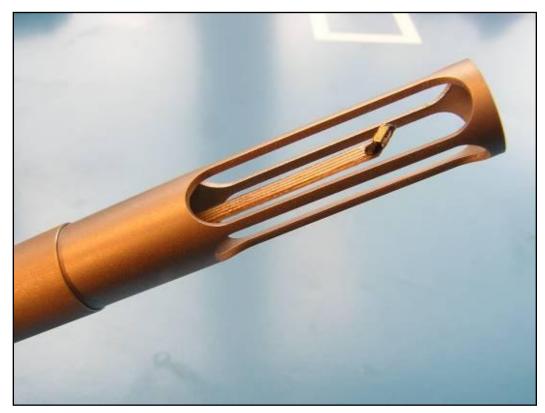
Influence of Magnetic Fields



Active Intensity

Magnetic Field of 6 Tesla





Scanning Probes

- 1D Velocity
- For small object
- High temperatures
- Non contact vibration

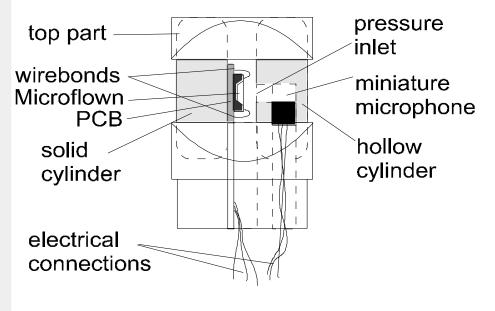


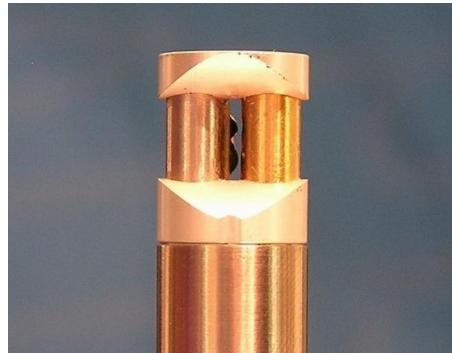
PU probes

- Particle Velocity
- Sound Pressure
- 1D Sound Intensity
- 1D Sound Energy
- Impedance



PU Probes: Placement of p and u









Metal Mesh

- Protecion of the wires
- Wind shield, DC flow up to 2 m/s
- Calibration including mesh

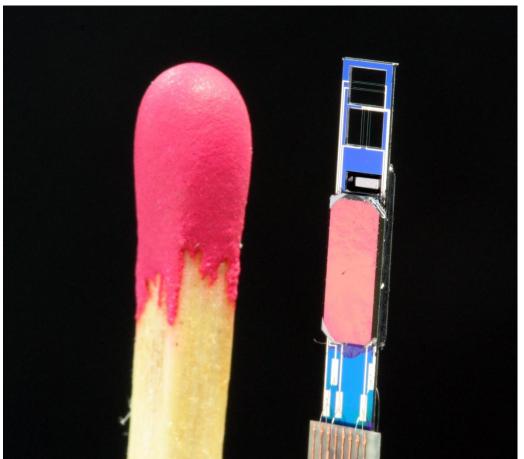




USP probes

- 3D Particle Velocity
- Sound Pressure
- 3D Sound Intensity
- 3D Sound Energy
- Impedance
- Acoustic Vector Sensor





3D Sound Chip



Application examples

- Hostile fire localization
- Air to ground applications (PGM, UAV's, etc.)
- Border control (passive, unattended ground sensor node)
- Passive surveillance (also in urban environment)
- Environmental monitoring
- Etc.







Standard signal conditioner



Power Gain Correction Power Input 18VDC

Standard probes

Standard signal conditioner

- Powering the sensor
- High or low gain setting
- Option for hardware correction



High dB Scanning Probe

- Above 135dB acoustics becomes non linear
- Standard sensor overloads at 130dB
- Measurement at 170dB is possible with packaged sensor





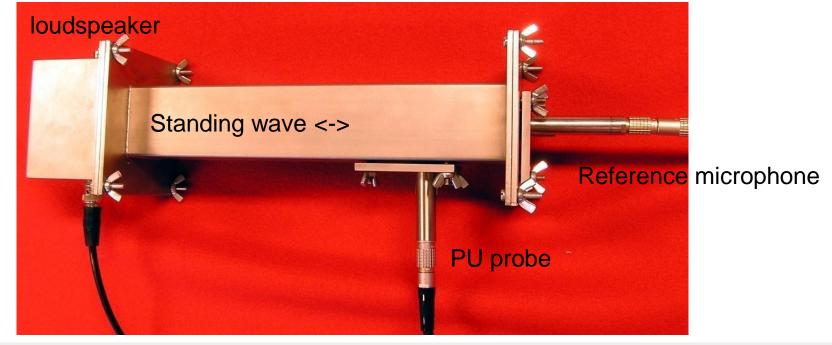




Calibration

Standing Wave Tube

Loudspeaker on one side, reference pressure microphone at the other side in the tube, known relation between pressure at the end and pressure and velocity in the tube. Limited bandwith of 20Hz – 4kHz





Calibration

Piston on a Sphere

Known relation between sound pressure and particle velocity in front of the speaker. And the vibration just in front of the speaker.

Use a reference pressure microphone to calibrate the Microflown probe.

